

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Etienne QUESNEL

Application No.: New U.S. Patent Application

Filed: March 18, 2004

Docket No.: 119144

For: OPTICAL DEVICE WITH ENHANCED MECHANICAL STABILITY OPERATING IN  
THE EXTREME ULTRAVIOLET AND LITHOGRAPHY MASK COMPRISING SUCH A  
DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of reference Nos. 3-4 is discussed in the present specification.
- ☒ 3. The references were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.
- ☒ 4. The present application was filed or entered the U.S. National Stage of the PCT after June 30, 2003. In accordance with the June 11, 2003, Notice waiving the requirements of 37 C.F.R. §1.98(a)(2)(i), copies of any U.S. patents and patent application publications are not attached.

Respectfully submitted,



William P. Berridge  
Registration No. 30,024

Thomas J. Pardini  
Registration No. 30,411

WPB:TJP/mxm  
Date: March 18, 2004

**OLIFF & BERRIDGE, PLC**  
**P.O. Box 19928**  
**Alexandria, Virginia 22320**  
**Telephone: (703) 836-6400**

DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
--

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 119144		APPLICATION NO. New U.S. Patent Application	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANT Etienne QUESNEL			
				FILING DATE March 18, 2004			

  

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
	1	US 6,396,900 B1	5/28/2002	BARBEE et al.		
	2	5,310,603	5/10/1994	FUKUDA et al.		

  

FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS

  

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)		
	3	DRÜSEDAU et al. "THE HYDROGENATED AMORPHOUS SILICON/NANODISPERSE METAL (SIMAL) SYSTEM - FILMS OF UNIQUE ELECTRONIC PROPERTIES," Journal of Non-Crystalline Solids 198-200 (1996) 829-832.
	4	KIM et al. "ANNEALING EFFECTS ON a-SiC:H AND a-SiC:H(F) THIN FILMS DEPOSITED BY PECVD AT ROOM TEMPERATURE," Thin Solid Films 261 (1995) 192-201.

  

EXAMINER	DATE CONSIDERED
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Date: March 18, 2004